

Cristian **Pira**

On behalf of INFN LNL SRF group

# New Technologies in Superconducting RF



First FCC-Italy Workshop  
Rome, March 21, 2022



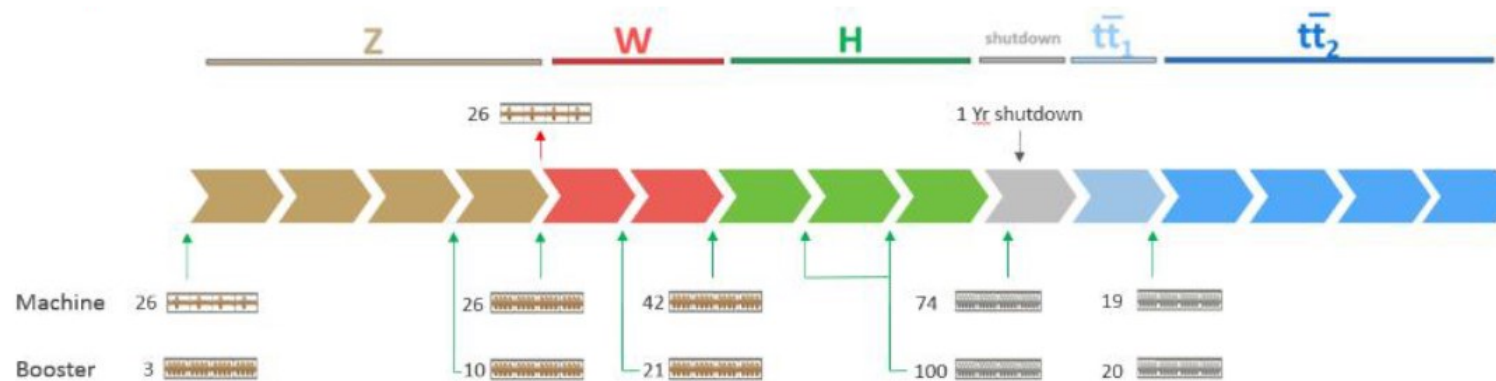
# Outline

**State of the  
art for FCC  
SRF cavities**

**R&D on  
substrate  
preparation**

**R&D on SC  
coatings**

# FCC SRF cavities choice



O. Brunner et al., FCC Week 2021

The **machine** will strongly **change configuration** during its lifetime

# FCC SRF cavities choice

WP	$V_{rf}$ [GV]	#bunches	$I_{beam}$ [mA]
Z	0.1	16640	1390
W	0.44	2000	147
H	2.0	393	29
ttbar	10.9	48	5.4

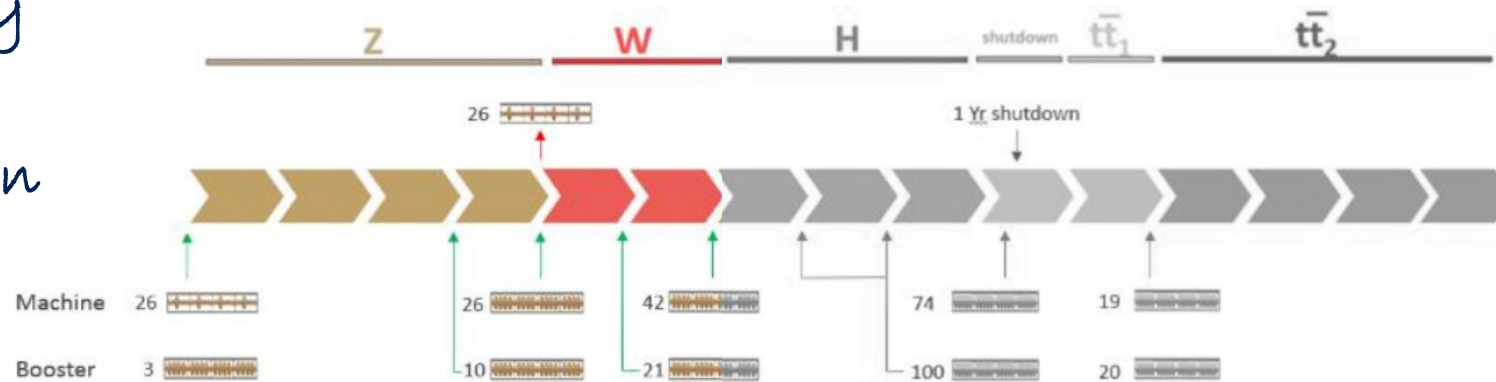
High Current Machine

Low frequency cavities

4.5 K operation

400 MHz

Nb thin films



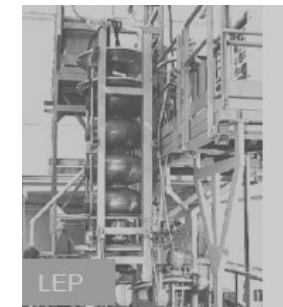
O. Brunner et al.

FCC Week 2021

1 cell  
104 cavities  
 $E_{acc} = 5$  MV/m  
1 MW/cav  
4cav./cryom  
Re-used for FCC-hh.



4 cell  
408 cavities  
 $E_{acc} = 10$  MV/m  
1 MW to 200 kW/cav  
4cav./cryom



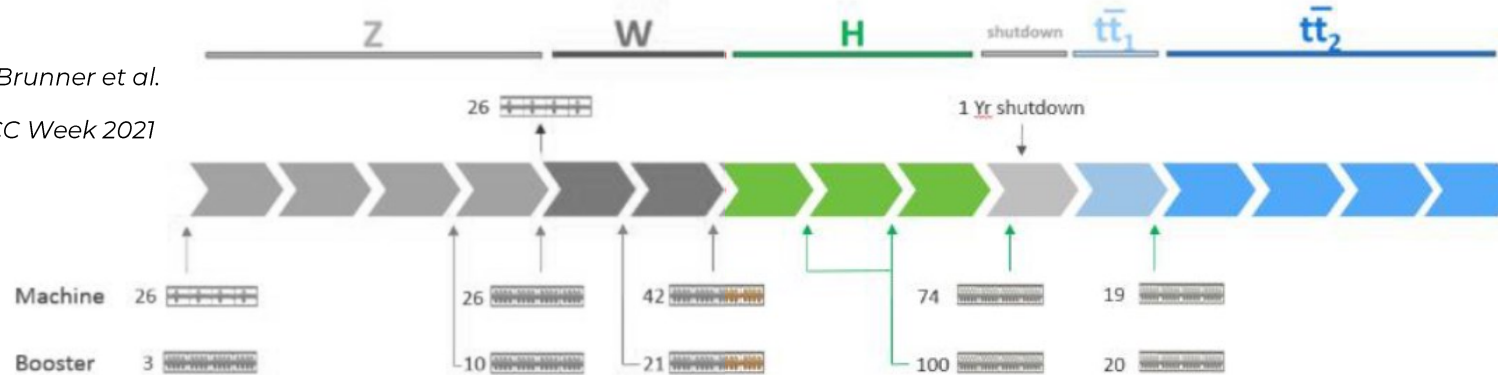
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High gradient Machine

O. Brunner et al.

FCC Week 2021



High gradient cavities

2K operation

5 cell  
852 cavities  
 $E_{acc} = 20$  MV/m  
200 kW/cav  
4cav./cryom.



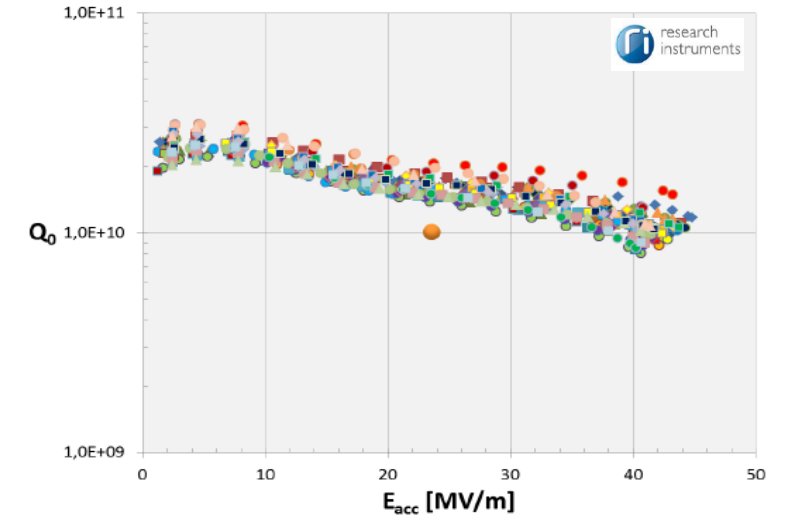
800 MHz  
Nb bulk

# Nb bulk state of the art



768 Nb bulk TESLA type elliptical 1.3 GHz cavity

**Accelerating Gradient closer to Nb theoretical limits**



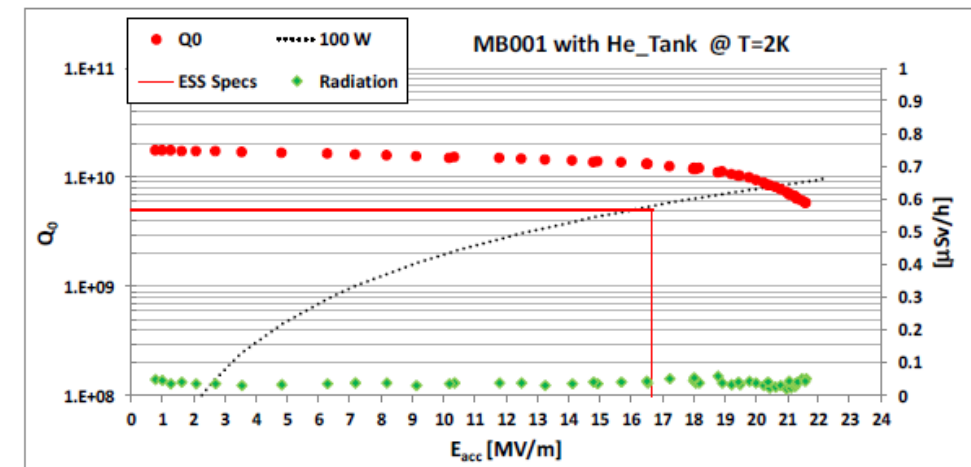
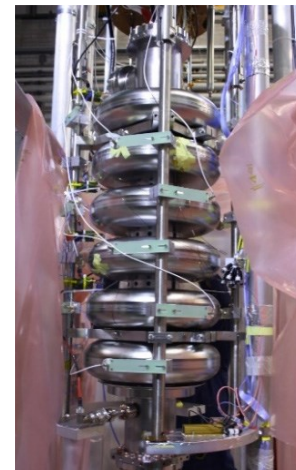
Technology

already transferred at lower frequency (650 MHz)

Performances closer to FCC requirement



EUROPEAN  
SPALLATION  
SOURCE



D. Sertore, Proceedings SRF 2017



# Nb bulk state of the art



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**Accelerating Gradient closer to Nb theoretical limits**

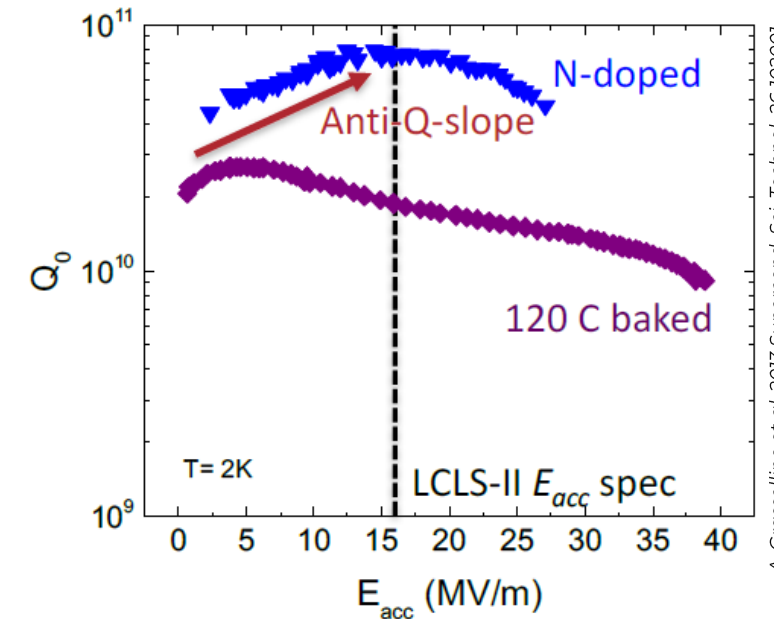
Technology

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Performances closer to FCC requirement



EUROPEAN  
SPALLATION  
SOURCE



A. Grassellino et al, 2013 Supercond. Sci. Technol. 26 102001

**Room for Quality factor improvement**

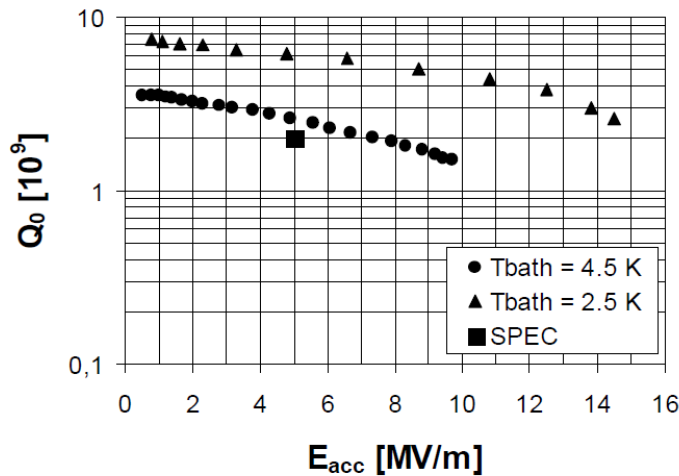
**Nitrogen Doping technology**

Some drawbacks to take in account:

- Less effective at 800 MHz
- High sensitivity to flux trapping

# Nb on Cu state of the art

S. Bauer et al., "Production of Nb/Cu sputtered superconducting cavities for LHC," 1999



21 elliptical 400 MHz cavities  
produced by industry (ACCEL)

## LHC

### DC magnetron Sputtering Technology



Advantages:

*Cheaper*

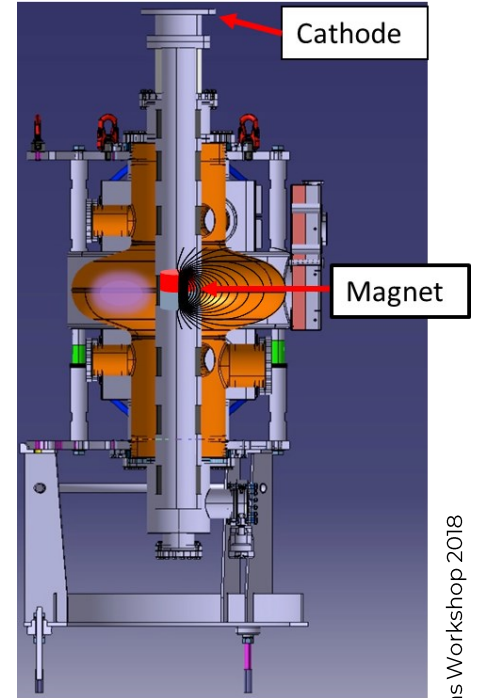
*Cu almost 100 times cheaper than Nb*

*4.5 K operation*

*Better thermal properties, low BCS resistance*

*Simpler cryostat design*

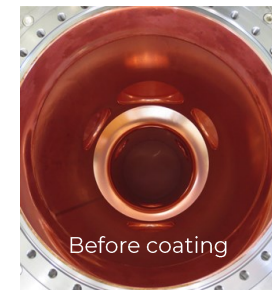
*No magnetic screening necessary*



LHC cavity coating setup

## Still room for improvements

*( $\alpha$ -slope at high gradients)*



Before coating



After coating

A. Sublet, Thinfilms Workshop 2018

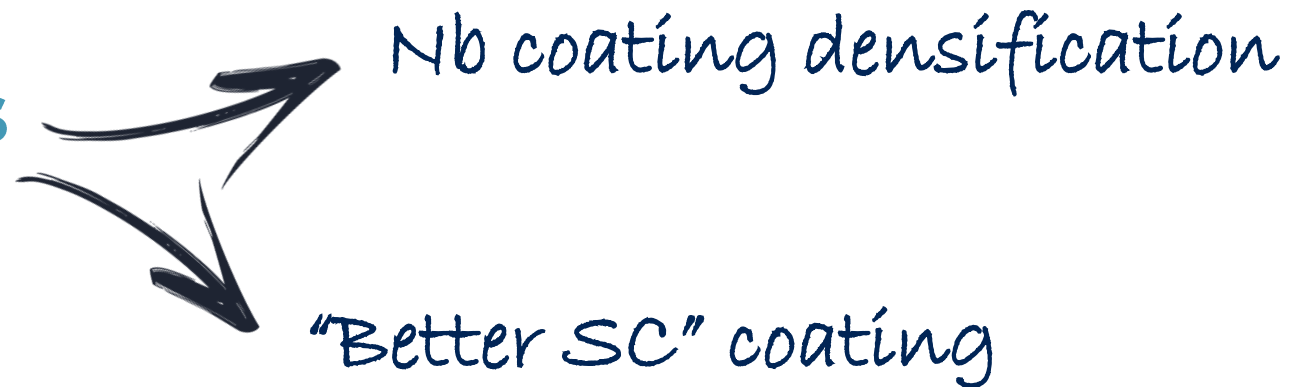


# Nb on Cu R&D

**Cu substrate plays a fundamental role in SRF performances**

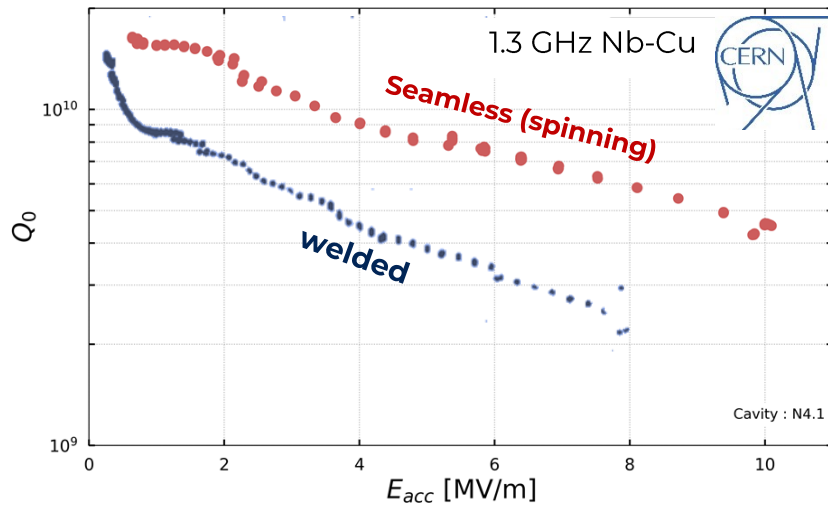


**Sputtering technology offers a wide range of optimization**



# Nb on Cu R&D

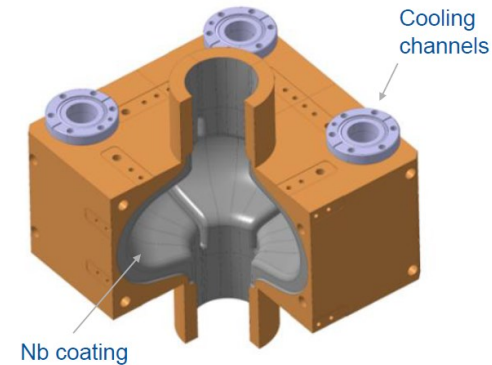
Cu substrate plays a fundamental role in SRF performances



L. Vega Cid, TTC meeting 2022 (elaborated)

→ Cavity fabrication

Different possibilities:  
Welding/seamless  
Spinning, hydroforming,  
electroforming...



SWEEL cavity  
Simpler coating  
procedure

Different proofs of **seamless** RF performances **superiority**

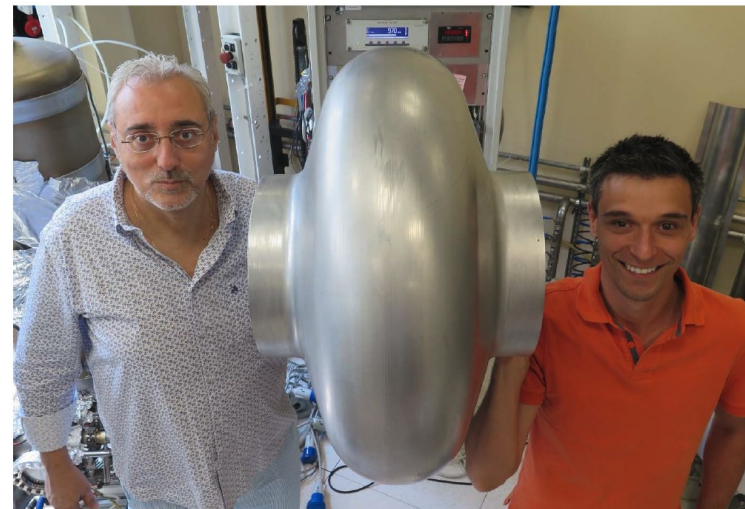
(Hie-ISOLDE, ALPI-INFN, CERN studies, ...)

# Seamless Cavity Fabrication @LNL



## Forming via spinning of seamless 400 MHz accelerating cavities

2015-2019 Collaboration Agreement KE2722/BE/FCC



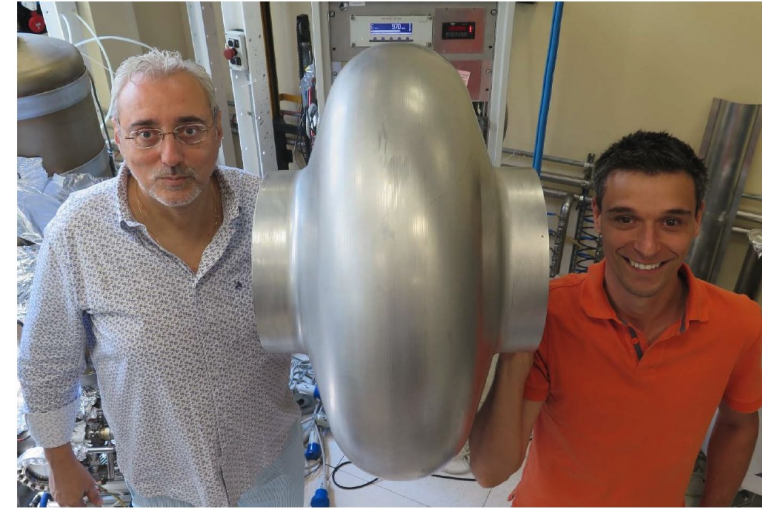
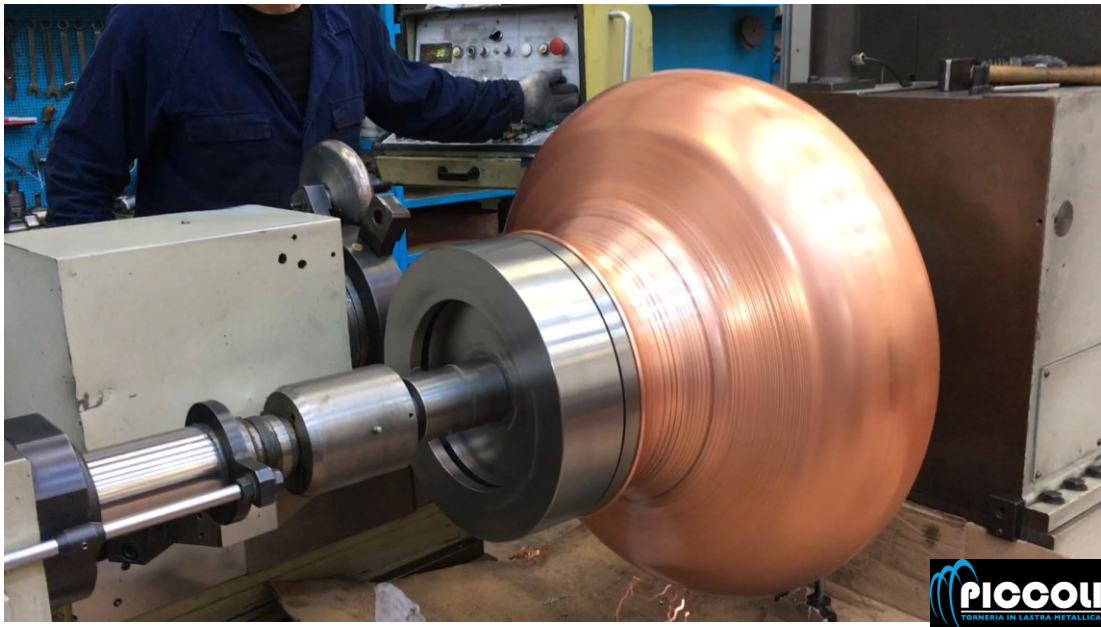
First Aluminum Prototype by Enzo Palmieri

# Seamless Cavity Fabrication @LNL



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First Aluminum Prototype by Enzo Palmieri



**Two** Copper 400 MHz **seamless Prototype** realized



# Seamless Cavity Fabrication @LNL



## Forming via spinning of seamless 400 MHz accelerating cavities

2015-2019 Collaboration Agreement KE2722/BE/FCC



Azzolini et al, SRF2019 proceedings

**3 intermediate  
annealings solve  
large cracks issue**



Cavity 1

Deep circumferential  
cracks on the iris



**Two** Copper 400 MHz **seamless Prototype** realized

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## Forming via spinning of seamless 400 MHz accelerating cavities

2015-2019 Collaboration Agreement KE2722/BE/FCC



Azzolini et al, SRF2019 proceedings

**3 intermediate  
annealings solve  
large cracks issue**



Cavity 1

Deep circumferential  
cracks on the iris

**Further developments are necessary to:**

- Increase iris thickness to prevent cracks
- increase geometry accuracy
- Increase internal surface quality



**Two** Copper 400 MHz **seamless Prototype** realized



# Seamless Cavity Fabrication @LNL

*On-going R&D*

**CNC Machine process evaluation** on 1.3 GHz cavities to increase process reproducibility and geometrical accuracy of seamless spinning

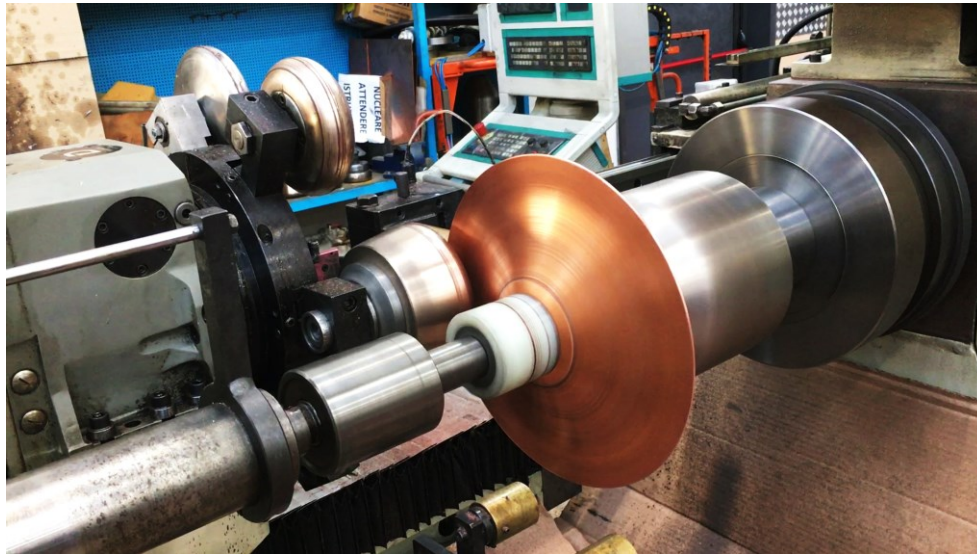


UNIVERSITÀ  
DEGLI STUDI  
DI PADOVA



WP9

WP10

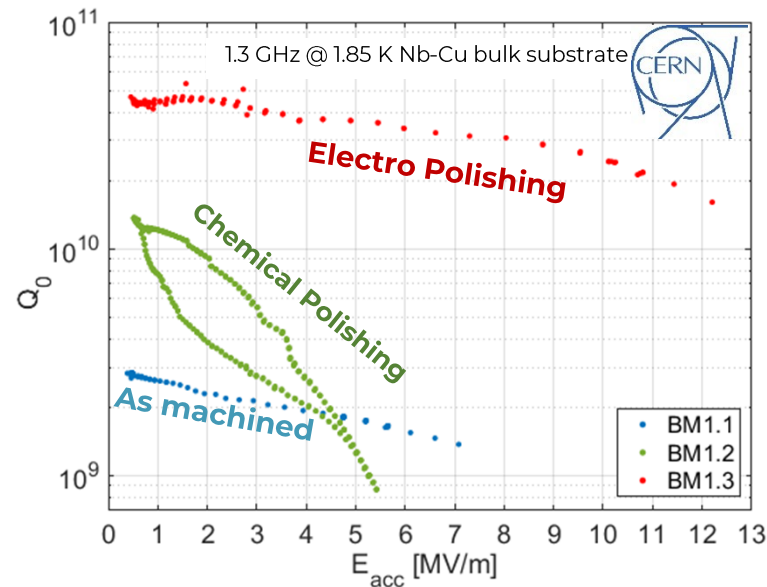


Proof of concept of **additive manufacturing** production for **SRF** applications on 6 GHz cavities



# Nb on Cu R&D

Cu substrate plays a fundamental role in SRF performances



L. Vega Cid, TTC meeting 2022 (elaborated)

Roughness and defects reduction by **surface treatments are mandatory** for a good and uniform SRF coating

Cavity polishing requires **large amount of acids**. In particular **Nb** requires **HF** (extremely dangerous and poisoning process)



# Plasma Electrolytic Polishing @LNL

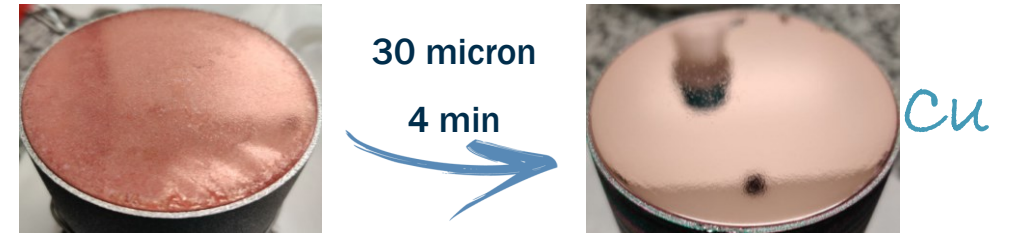
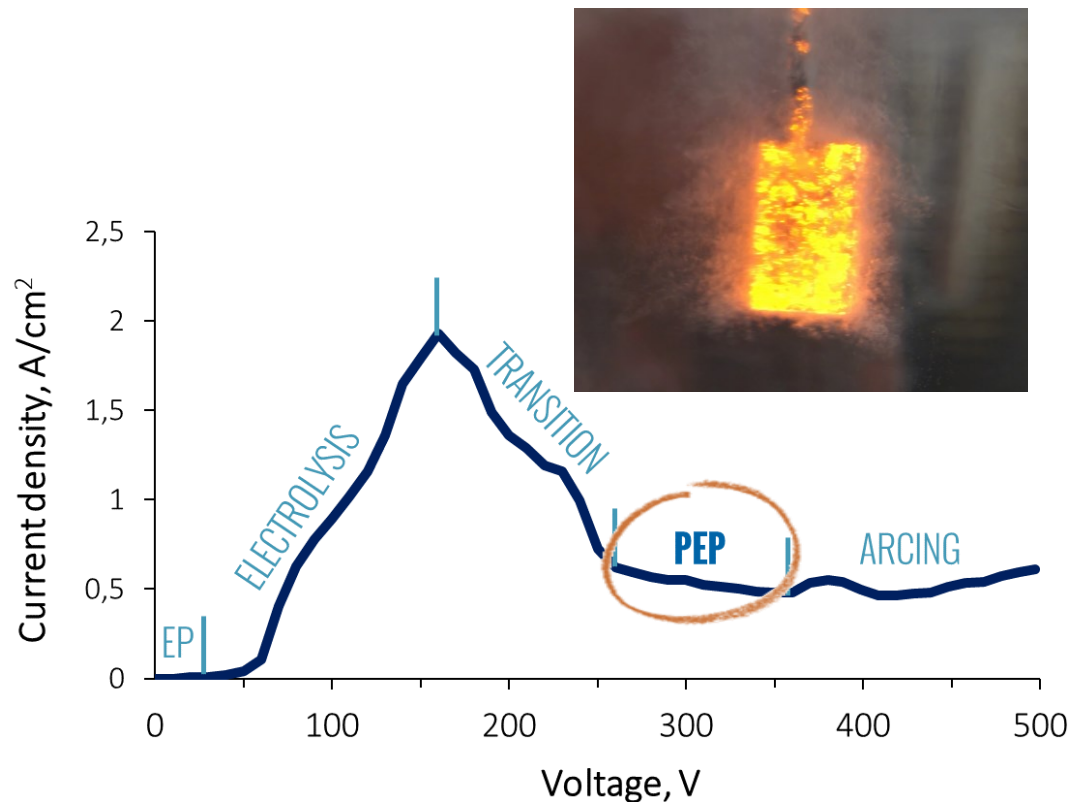
On-going R&D SAMARA

CSN5 INFN experiment

Identical EP set-up

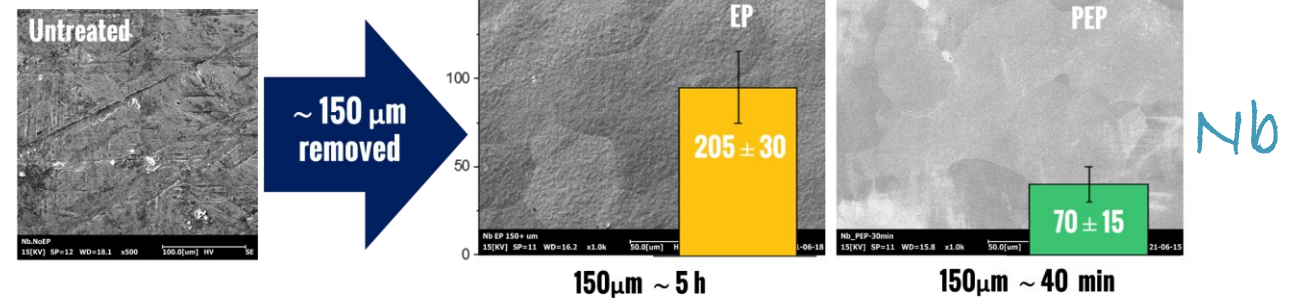
Different I-V conditions

Diluted salts solutions



Pira et al., SRF2021 proceedings

Roughness  $R_a$  (nm)



Compared to standard electropolishing:

**10 times faster and 3 times more efficient**

**Safer and more eco-friendly than EP**

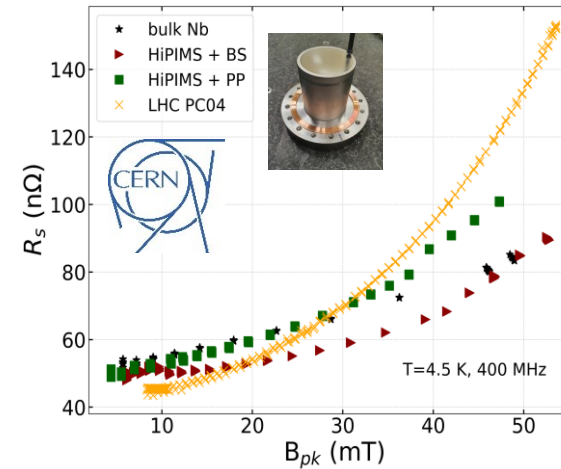
**Polishing of large areas challenging**

# Nb on Cu R&D

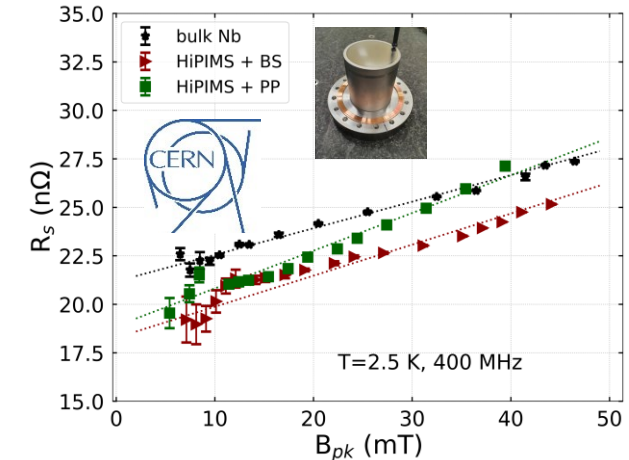
**Q-slope** has been shown to be partially due to porosities present in the films.

**Energetic Condensation Techniques** (ECR, HiPIMS) increase film density

Marco Arzeo *et al* 2022 *Supercond. Sci. Technol.* in press  
<https://doi.org/10.1088/1361-6668/ac5646>



**Q slope mitigation**



**Rs = 9-18 nΩ @ 2 K**

**Sputtering technology offers a wide range of optimization**



Nb coating densification



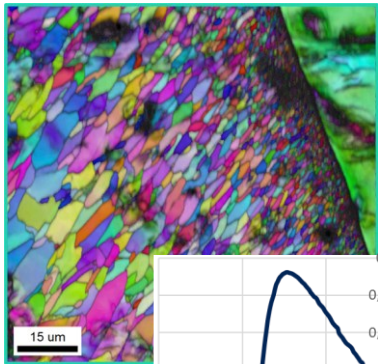
# Nb on Cu Thick Films @LNL

TEFEN CSN5 INFN experiment

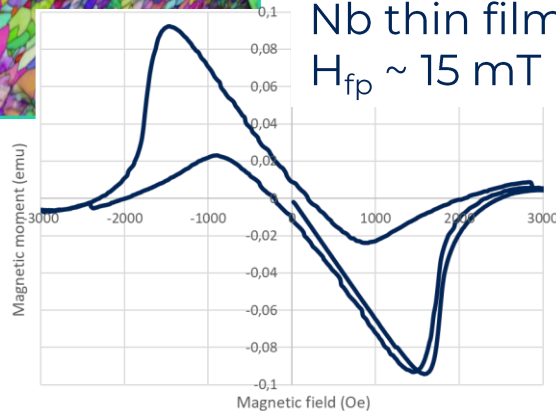


LNL Approach for densification:

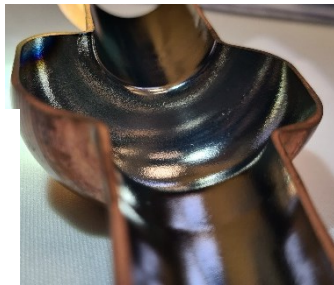
Thick film ( $>40 \mu\text{m}$ ) + High Substrate T ( $550^\circ\text{C}$ )



Nb Thick film:  
 $H_{fp} \sim 145 \text{ mT}$   
Nb thin film  
 $H_{fp} \sim 15 \text{ mT}$

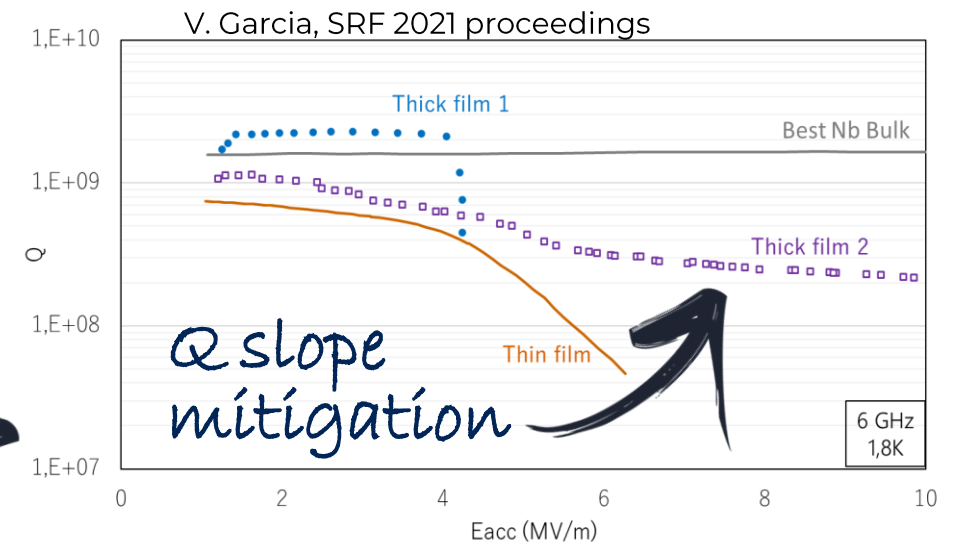
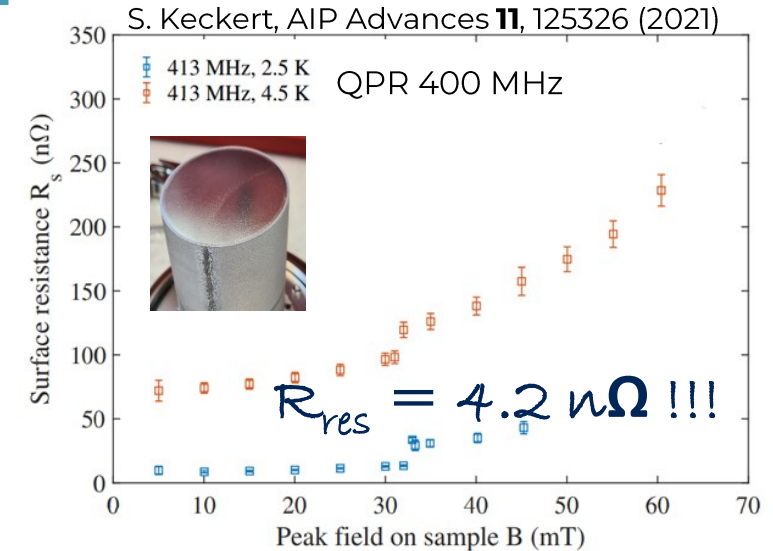


EBSD and Magnetometry on Thick film 6 GHz cavity  
courtesy of STFC



Investigation on  
6 GHz cavities

Nb Bulk Like  
Properties



# Coated cavities R&D

**Nb<sub>3</sub>Sn** looks  
a good choice

Material	T <sub>c</sub>	H <sub>sh</sub>
Nb	9.2 K	0.2 T
Nb <sub>3</sub> Sn	18.3 K	0.4 T

DOUBLE  
ACCELERATING  
FIELD

60% DECREASE IN  
CRYOGENIC COSTS

Sputtering  
technology offers  
a wide range of  
optimization

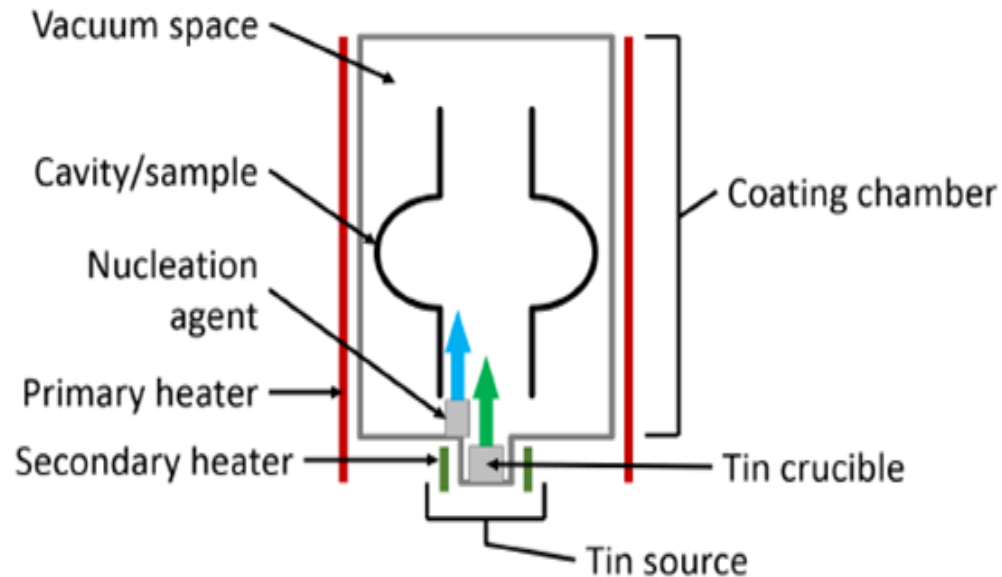
Nb coating densification

"Better SC" coating



# $\text{Nb}_3\text{Sn}$ State of the art

## Vapour Tin Diffusion



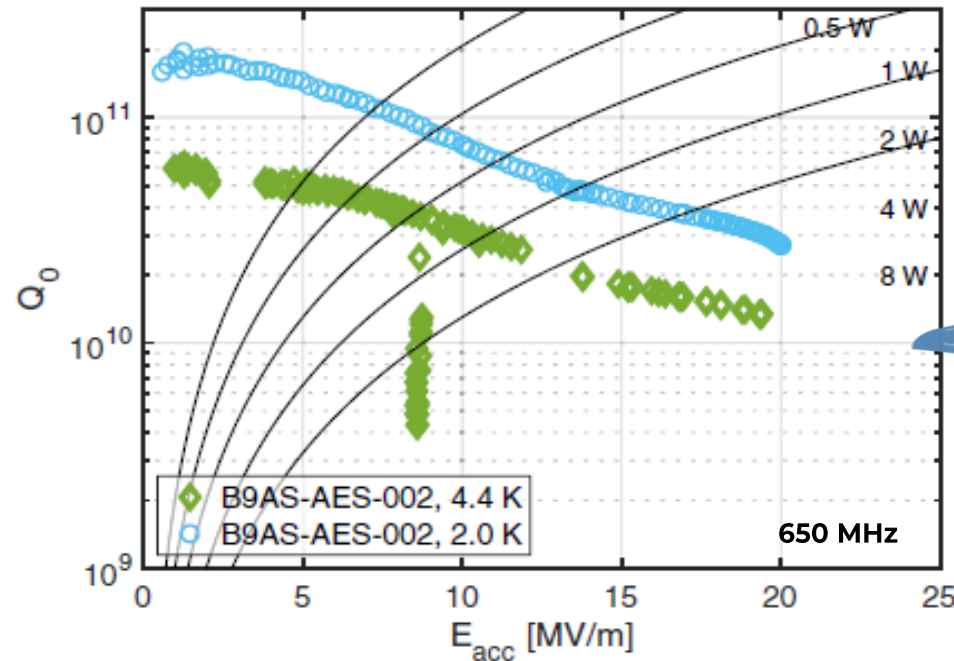
# Nb<sub>3</sub>Sn State of the art

## Vapour Tin Diffusion

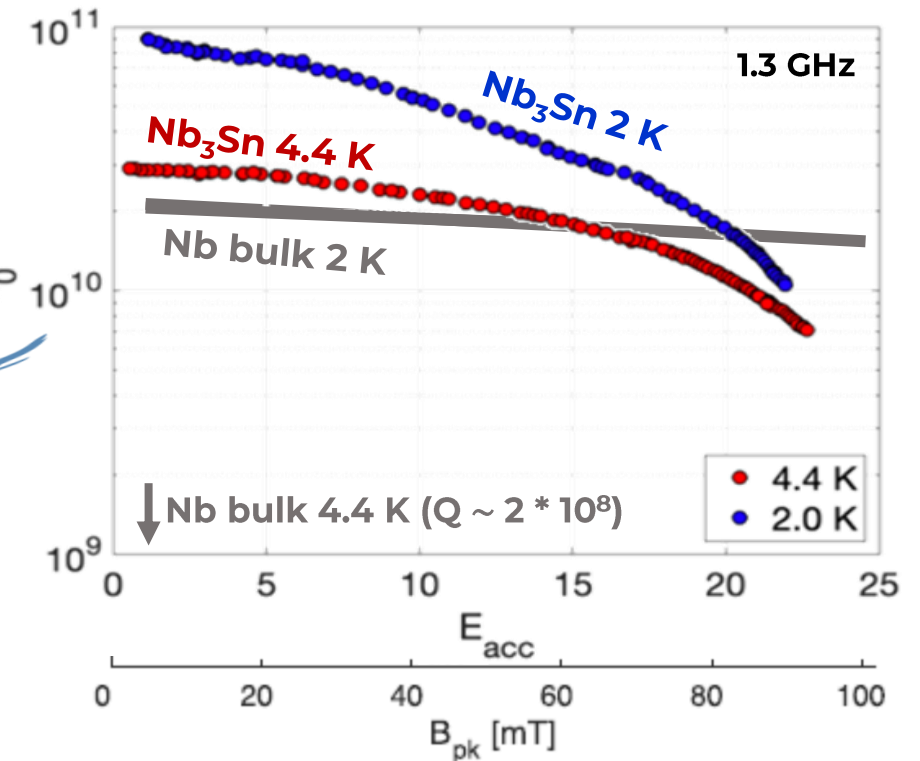
$Q_0$  @ 4.4 K comparable to Nb bulk @ 2K

main limit

Needed Nb bulk cavities  
Not possible on Cu



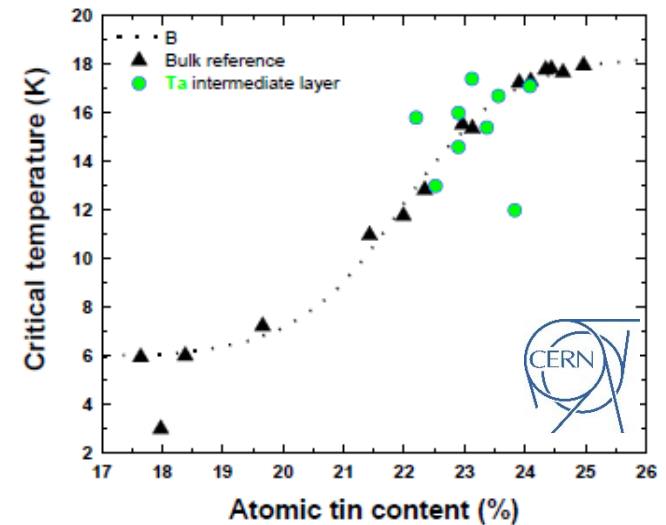
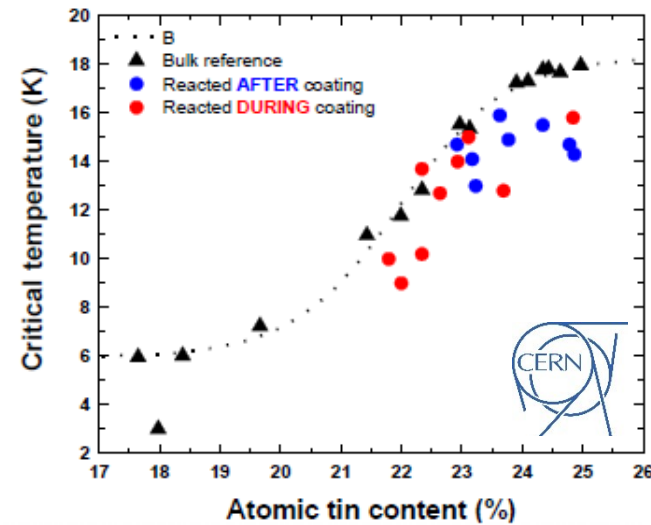
S. Posen, SRF 2019 proceedings



S. Posen, SRF 2019 proceedings (elaborated)

# Nb<sub>3</sub>Sn on Cu by Sputtering

- R&D @ CERN and others
- Good T<sub>c</sub>
- Few RF test yet



**Scale up will be challenging!**  
(cylindrical target not available)

# Nb<sub>3</sub>Sn on Cu by Sputtering @ LNL

*On-going R&D*



**SAMARA**  
CSN5 INFN experiment

GOAL:

1.3 GHz Nb<sub>3</sub>Sn on Cu elliptical cavity ready in 2025

## Exploration of different scale up configurations

on 6 GHz and 1.3 GHz cavities

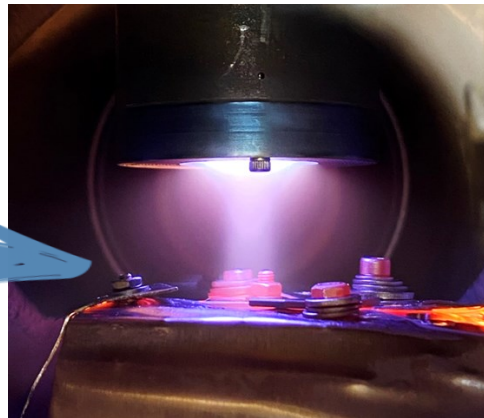
# Nb<sub>3</sub>Sn on Cu by Sputtering @ LNL

Nb<sub>3</sub>Sn target by Dipping

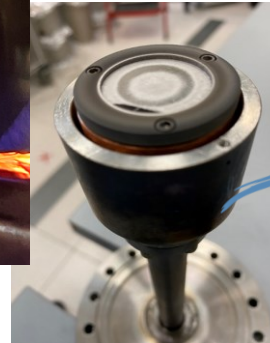
**Proof of concept** successfully done:



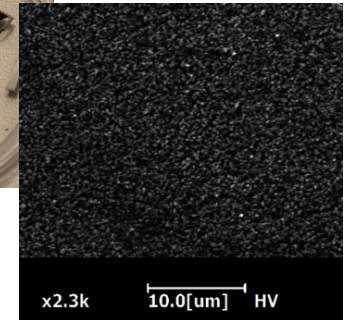
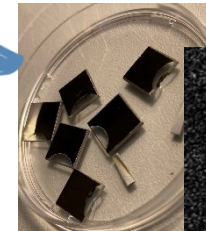
**Up to 50 microns Nb<sub>3</sub>Sn**  
on 1" Nb planar target



Coating on Quartz by  
Magnetron Sputtering



1 microns Nb<sub>3</sub>Sn  
**76% Nb – 24% Sn (EDS)**



Zanierato et al,  
SRF Proceedings 2021

Next step: cylindrical target for 6 GHz cavities

# Conclusions

Many possible **points of common interest** for a **collaboration** in FCC, in particular regarding **coating cavities**, on:

- ➔ **Forming technology**
- ➔ **Surface Preparation**
- ➔ **Nb and Nb<sub>3</sub>Sn coatings**



# Thank you!

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EASITrain This Marie Skłodowska-Curie Action (MSCA) Innovative Training Networks (ITN) receives funding from the European Union's H2020 Framework Programme under GA no. 764879

